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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2814  
Examiner: Long PHAM

In Re PATENT APPLICATION Of:

Applicants : Jiro MATSUMOTO )  
 )  
Appln. No. : 10/727,662 )  
 )  
Filed : December 5, 2003 )  
 )  
For : SEALING APPARATUS FOR )  
 SEMICONDUCTOR WAFER, MOLD OF )  
 SEALING APPARATUS AND )  
 SEMICONDUCTOR WAFER )

**RESPONSE**

Attorney Ref.: F00ED0150-DIV )

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May 16, 2007

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Examiner's Office Action mailed February 27, 2007,  
please reconsider the above-identified application as follows: